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Dated: February 18, 2005

Signature: 
(Marco Jimenez)



Docket No.: 514802002600
Client reference: AD-0371US
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Mitsuyuki ASAHI et al.

Confirmation No.: 4476

Application No.: 10/664,440

Examiner: Johnnie L. Smith

Filed: September 18, 2003

Art Unit: 2881

For: PATTERN WIDTH MEASURING
APPARATUS, PATTERN WIDTH
MEASURING METHOD, AND ELECTRON
BEAM EXPOSURE APPARATUS

RCE processed
4/21/05
AMW

AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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BT
DPC
RFB
3/21/05
Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated November 18, 2004, for which a response is due on February 18, 2005, please amend the above-identified U.S. patent application as follows: